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CONFIRMATION NO. 1042

<b>SERIAL NUMBER</b> 10/631,848	<b>FILING OR 371(c) DATE</b> 08/01/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2891	<b>ATTORNEY DOCKET NO.</b> 9862-000014/US	
<b>APPLICANTS</b> Ju-Seon Goo, Suwon, KOREA, REPUBLIC OF; Eun-Kee Hong, Suwon, KOREA, REPUBLIC OF; Hong-Gun Kim, Suwon, KOREA, REPUBLIC OF; Kyu-Tae Na, Seoul, KOREA, REPUBLIC OF;					
<b>** CONTINUING DATA *****</b> <i>NONE CME</i>					
<b>** FOREIGN APPLICATIONS *****</b> <i>NONE CME</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 10/29/2003</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>Chuehmark</i> Allowance Examiner's Signature Initials		<b>STATE OR COUNTRY</b> KOREA, REPUBLIC OF	<b>SHEETS DRAWING</b> 13	<b>TOTAL CLAIMS</b> 51	<b>INDEPENDENT CLAIMS</b> 4
<b>ADDRESS</b> 30593					
<b>TITLE</b> Method for forming a silicon oxide layer using spin-on glass					
<b>FILING FEE RECEIVED</b> 1392	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		